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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

*SAK Non*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

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JAPAN 2000-311124 10/11/2000

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 23	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>SAK</i> Initials				

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## TITLE

Film formation method, semiconductor element and method thereof, and method of manufacturing a disk-shaped storage medium

FILING FEE  RECEIVED 764	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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